



EXPEDITED PROCEDURE - EXAMINING GROUP 1744

N 10/692,881

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	Sharone Gindel	Examiner:	Theresa T. Snider
Serial No.:	10/692,881	Group Art Unit:	1744
Filed:	October 24, 2003	Docket No.:	884.422US2
Title:	VACUUM DEBRIS REMOVAL SYSTEM FOR AN INTEGRATED CIRCUIT MANUFACTURING DEVICE		
Assignee:	Intel Corporation	Customer No.:	21186

AMENDMENT & RESPONSE UNDER 37 C.F.R. 1.116

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

*OK to
enter
TIS
6/22/05*

In response to the Final Office Action mailed March 7, 2005, please amend the application as follows:

06/10/2005 MAHME1 00000010 10692881

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